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Substitute for form 1449/PTO		INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as needed)		Complete if Known Application Number: 10/810,962 Filing Date: March 26, 2004 First Named Inventor: RUECKES et al. Art Unit: 2827 2827 Examiner Name: TBA Huan Hoang Attorney Docket Number: 112020.145YS2 NAN-21	
Sheet	1	of	4		

U. S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			
HL		US 2002/0130311 A1	09-19-2002	LIEBER et al.	
		US 2002/0130353 A1	09-19-2002	LIEBER et al.	
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Examiner Signature	Huan Hoang	Date Considered	5/1/05
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STATEMENT BY APPLICANT (Use as many sheets as necessary)		Application No. 10/810,962 Filing Date 3/26/04	
		First Named Inventor RUECKES et al. Art Unit 2827 2827 Examiner Name JBA Huan Hoang Attorney Docket Number 112020.145YS2 NAN-21	
Sheet	2	of	4

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Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			
HU		WO 01/44796 A1	06-21-2001	Board of Trustees of the Leland Stanford Junior. University.	
HU		WO 01/03208 A1	01-11-2001	President and Fellows of Harvard College	

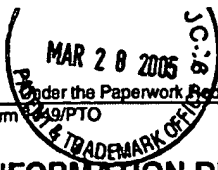
NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, volume-issue number(s), page(s), publisher, city and/or country where published.	T ²
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Examiner Signature	Huan Hoang	Date Considered	5/1/05
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Substitute for form PTO		Complete if Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)		Application Number	10/810,962
		Filing Date	March 26, 2004
		First Named Inventor	RUECKES et al.
		Art Unit	2827 2827
		Examiner Name	TBA Huan Hoang
		Attorney Docket Number	112020.145YS2 NAN-21
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	A7	DAI, H. et al., "Controlled Chemical Routes to Nanotube Architectures, Physics, and Devices." <i>J. Phys. Chem. B</i> , 1999, Vol. 103, 111246-11255.	
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	A15	FUHRER, M.S. et al., "High-Mobility Nanotube Transistor Memory." <i>Nano Letters</i> , 2002, Vol. 2(7) 755-759.	
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Examiner Signature	Huan Hoang	Date Considered	5/1/05
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<p style="text-align: center;">INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)</p>			<p style="text-align: right;">03/28/05</p>		
			Application No. 10/810,962		
			Filing Date March 26, 2004		
			First Named Inventor RUECKES et al.		
			Art Unit 2827 2827		
Examiner Name TBA Huan Hoang			Attorney Docket Number 112020.145YS2 NAN-21		
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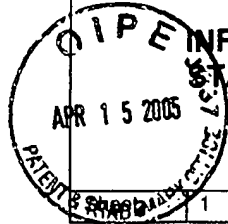
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Complete if Known

Application No.	10/810,962
Filing Date	March 26, 2004
First Named Inventor	RUECKES, et al.
Art Unit	2010 2827
Examiner Name	IBA Huan Hoang
Attorney Docket Number	112020.145 US2 NAN-21

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

(Use as many sheets as necessary)



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Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ^{2(f) known}			
HL		US-6,548,841	04-15-2003	FRAZIER et al.	
		US-6,803,840	10-12-2004	HUNT et al.	
HL		US-6,809,465	10-26-2004	JIN	
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		Number-Kind Code ^{2(f) known}			
HL		WO 04/065657	08-05-2004	Nantero, Inc.	

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Signature

Huan Hoang

Date
Considered

5/1/05

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